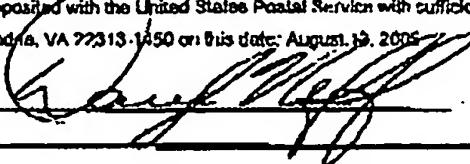


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I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MS AF, Commissioner for Patents, Alexandria, VA 22313-1450 on this date: August 13, 2005.

Name of Depositor: Daryl K. Neff

Signature 

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Michael P. Belyansky, et al.	Date: August 13, 2005
Serial Number: 10/605,889	Examiner: Long Pham
Filed: November 4, 2003	Group Art Unit: 2814
Title: OXIDATION METHOD FOR ALTERING A FILM STRUCTURE AND CMOS TRANSISTOR STRUCTURE FORMED THEREWITH	IBM Corporation D/18G, B/300, Zip 482 2070 Route 52 Hopewell Junction, NY 12533-6531

AMENDMENT

MS AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated August 9, 2005, Applicants submit the following amendments and remarks.

FIS920030286US1